

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

71B  
12-11-00  
C. Brown

Applicant : Hidemi Takasu  
Serial No. : 09/212,915 Examiner: M. Estrada  
Filed : December 16, 1998 Group Art Unit: 2823  
For : PROCESS FOR FABRICATING A  
SEMICONDUCTOR DRIVE



AMENDMENT

I hereby certify that this paper is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  
Assistant Commissioner for Patents, Washington, D.C. 20231, on:

November 29, 2000

Date of Deposit

Francis J. Hone

Attorney Name

[Signature]  
Signature

18,662

PTO Reg. No.

November 29, 2000

Date of Signature

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

RECEIVED  
DEC 08 2000  
TECHNOLOGY CENTER 2800

In response to the Examiner's Action mailed August 30, 2000, please amend the  
above-identified application as follows:

In the Specification:

Page 1, line <sup>2</sup>/<sub>3</sub>, change "of" to --on--.

(c)

ME  
02/12/01